

Substitute for form 1449A/PTO

Atty. Docket No.

P30564US

Serial No.

09/822,115

**SUPPLEMENTAL INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Applicant

Roald G. van Borselen

Examiner Name

Anthony Gutierrez

Page 1 of 1

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3/30/2001

Group

2862

U.S. Patent Documents

See Page 1

Foreign Patent Documents

See Page 2

Other Art

See Page 2

U.S. Patent Documents

Exam. Init.	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	A1				
	A2				
	A3				
	A4				
	A5				
	A6				
	A7				
	A8				
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Roald G. van Borselen	Examiner Name Anthony Gutierrez
Page 2 of 1		Filing Date 3/30/2001	Group 2862
Patent Documents See Page 1	Foreign Patent Documents See Page 2	Other Art See Page 2	

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1						
	B2						
	B3						
	B4						
	B5						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
AG	C1	Sheriff, R., Surface-Related Multiple Elimination, an Inversion Approach, Encyclopedic Dictionary of Exploration Geophysics Third edition, 1 Geophysical References Series, 1991, pp. cover page, title page, copyright page, pages 1 and 18.
AG	C2	Verschuur, E., Surface-Related Multiple Elimination, an Inversion Approach, PhJD thesis, Delft University, ISBN 90-9004520-1, 1991, pp. Cover page, copyright page, pages 1-5.
	C3	
	C4	
	C5	
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	C7	
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Page 3 of 1		Filing Date 3/30/2001	Group 2862
U.S. Patent Documents See Page 1		Foreign Patent Documents See Page 2	Other Art See Page 2

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Exam. Init.	Ref. Des.	Citation
	C15	
	C16	
	C17	
	C18	
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